

# Weekly Report 6

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*February 18<sup>th</sup> 2013 to February 25<sup>th</sup> 2013*

## General Information

Group Number: 13-25

Group Advisor: Professor Gary Tuttle

Client: Professor Gary Tuttle

## Accomplishments

- Continued mask testing. (will take several weeks)
- PMOS source/drain lithography was done.

## Plan for Coming Week

- Continue lithography mask testing at MRC

## Pending Issues

## Individual Contributions

Daniel O'Connell - 2 hours

Levi Weiss - 2 hours

Benjamin Ch'ng - 2 hours

Chen Wen - 2 hours

Liao Wang - 2 hours